

Electronic Patent Application Fee Transmittal

Application Number:	10694986
Filing Date:	29-Oct-2003
Title of Invention:	Method for removing resist pattern and method for manufacturing semiconductor device
First Named Inventor/Applicant Name:	Masaharu Nagai
Filer:	Roberto J. Devoto/kim bailey
Attorney Docket Number:	12732-171001

Filed as Large Entity

Utility under 35 USC 111(a) Filing Fees

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Claims in excess of 20	1202	16	52	832
Independent claims in excess of 3	1201	2	220	440

Miscellaneous-Filing:

Petition:

Patent-Appeals-and-Interference:

Post-Allowance-and-Post-Issuance:

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension-of-Time:				
Miscellaneous:				
Total in USD (\$)				1272